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**FACSIMILE TRANSMISSION COVER SHEET**

Date: February 6, 2006

To: United States Patent and Trademark Office  
Examiner: Chen, Kin Chan; Art Unit: 1765

Fax: (571) 273-8300

Re: **Application Serial No.: 10/705,347**  
Filing Date: 11/8/2003; First-Named Inventor: Labelle  
Attorney Docket No.: 0180151

From: Farjami & Farjami LLP

Number of pages including the cover sheet: 10

Message:

Enclosed please find the Response to Final Office Action dated December 7, 2005.

Thank you.

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Attorney Docket No.: 0180151

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Labelle, et al.**

Serial No.: **10/705,347**

Filing Date: **November 8, 2003**

For: **Method for Integrating a High-K  
Gate Dielectric in a Transistor  
Fabrication Process**

Art Unit: 1765

Examiner: CHEN, Kin Chan

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**RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Final* Office Action dated December 7, 2005 in the above-referenced patent application. Please enter and consider the following remarks.